

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: Unassigned
Examiner: Unassigned

In Re PATENT APPLICATION OF:

Applicants : Kazuhide ABE
Serial No. : Unassigned
Filed : January 28, 2004
For : METHOD OF FORMING BURIED
WIRING IN SEMICONDUCTOR
DEVICE
Attorney Ref. : MAE 306

INFORMATION
DISCLOSURE
STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

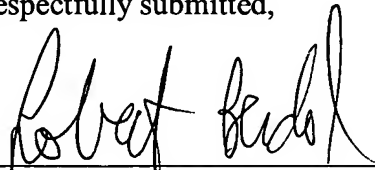
Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are copies of two Japanese publications. Any relevance of the Japanese publications can be gleaned from the attached English-language Abstracts, and from page 1 of the specification of the present application, where these documents are discussed. The documents are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)
RABIN & BERDO, P.C.
CUSTOMER NO. 23995
(202) 371-8976
(202) 408-0924 fax

January 28, 2004
Date

RHB:tz

FEE ENCLOSED: \$ 810
Please charge any further
fee to our Deposit Acc unit
No. 18-0002

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty Docket		Application No.	
				MAE 306		To Be Assigned	
				Applicant			
				Kazuhide ABE			
				Filing Date		Group Unit	
				January 28, 2004		To Be Assigned	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AH	2002-359244	12/13/02	Japan			Abstract
	AI	2000-003912	01/07/00	Japan			Abstract
	AJ						
	AK						
	AL						
	AM						
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AO						
	AP						
	AQ						
	AR						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							